

Message Text

CONFIDENTIAL

PAGE 01 STATE 070267
ORIGIN COME-00

INFO OCT-01 CIAE-00 DODE-00 EB-08 NSAE-00 USIA-06
TRSE-00 EUR-12 ERDA-05 ISO-00 /032 R

DRAFTED BY COM/OEA/RAGAREL:BAW
APPROVED BY EB/EWT: RWPRACHT
EPWALINSKY, DIR.PPD/OEA/BEWT
RPE

-----301500Z 046008 /43

R 300155Z MAR 77
FM SECSTATE WASHDC
TO USMISSION OECD PARIS
INFO AMEMBASSY WARSAW

C O N F I D E N T I A L STATE 070267

EXCON

E.O. 11652:XGDS-1

TAGS:ESTC, COCOM, UR

SUBJECT:EXPORT OF POWER SEMICONDUCTOR MANUFACTURING
FACILITY TO POLAND - IL 1355

REF: BEWT CASE NO 222653(RCA CORP.)

1) REF CASE DRAFTED FROM COMMERCE ON 3/17/77 WITH REQUEST
TO "WITHHOLD ACTION". USDEL NOW REQUESTED TO SUBMIT THIS
CASE TO COCOM WITHOUT CHANGE.
CHRISTOPHER

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01-Jan-1994 12:00:00 am
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: STRATEGIC TRADE CONTROLS, EXPORT LICENSES, SEMICONDUCTOR DEVICES, IL 1355
Control Number: n/a
Copy: SINGLE
Sent Date: 30-Mar-1977 12:00:00 am
Decaption Date: 01-Jan-1960 12:00:00 am
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 22 May 2009
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1977STATE070267
Document Source: CORE
Document Unique ID: 00
Drafter: BAW
Enclosure: n/a
Executive Order: X1
Errors: N/A
Expiration:
Film Number: D770109-0148
Format: TEL
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1977/newtext/t1977036/aaaaaerz.tel
Line Count: 44
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 1e30f8b7-c288-dd11-92da-001cc4696bcc
Office: ORIGIN COME
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 1
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: n/a
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 01-Mar-2005 12:00:00 am
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 3108061
Secure: OPEN
Status: NATIVE
Subject: EXPORT OF POWER SEMICONDUCTOR MANUFACTURING FACILITY TO POLAND - IL 1355
TAGS: ESTC, UR, US, COCOM
To: OECD PARIS
Type: TE
vdkgvwkey: odb://SAS/SAS.dbo.SAS_Docs/1e30f8b7-c288-dd11-92da-001cc4696bcc
Review Markings:
Margaret P. Grafeld
Declassified/Released
US Department of State
EO Systematic Review
22 May 2009
Markings: Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 22 May 2009